The Propagation Characteristics of Wave-Guiding Structures with Very Thin Superconductors; Application to Coplanar Waveguide YBA₂CU₃O_{7-x} Resonators

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Abstract—We have analyzed the propagation characteristics of wave-guiding structures with superconductors which are thin compared to the magnetic penetration depth. The complex propagation constant is evaluated within the framework of the modified spectral domain method without the need for numerical calculations in the complex plane. Good agreement is found with the results of other methods. The numerical analysis is instrumental in deducing results for the penetration depth and the surface resistance of $YBa_2Cu_3O_{7-x}$ thin films on sapphire with a $PrBa_2Cu_3O_{7-x}$ buffer layer. We confirm recent observations of a non-single-gap BCS temperature dependence.

I. INTRODUCTION

THE SURFACE impedance of superconductors is characterized by a low resistance and a relatively high reactance. This makes superconductors suitable for microwave applications, which are impossible if normal conductors are used. As a result of the low surface resistance, the power losses in superconductors are low, which offers the possibility of low-loss filters with a sharp frequency response [1], [2]. The surface reactance represents the stored energy in the superconductor. If the stored energy is increased at a constant level of transmitted microwave power, the phase velocity is reduced, since the energy flux remains the same. Therefore, the surface reactance has the effect of slowing down the electromagnetic wave. Transmission lines exhibit a high slowing factor if the geometry favors the stored energy relative to the transmitted energy. The stored kinetic energy of the charge carriers in a superconducting film increases as the thickness of the film is reduced below the magnetic penetration depth. This is a consequence of the increased current density necessary to support the same current or magnetic field. The transmitted energy on the other hand is reduced by choosing a small geometry. In this way very compact microwave devices, such as filters and delay lines, can be fabricated [3], [4]. The miniaturization is also made possible by the low surface resistance. In addition, the influence of the surface reactance also can be used to determine the penetration depth.

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Both the design of microwave devices and the characterization of the superconductors rely on the accurate calculation of the propagation characteristics of superconducting transmission lines. Superconducting microstrip lines with very slow phase velocities have been analyzed by a spectral domain method, modified by complex resistive boundary conditions [5]. The modification is necessary because of the coupling of the electromagnetic field from one side of the film to the other side. We will show that the complex propagation constant (attenuation and wave number) of different waveguiding structures can be evaluated within the framework of the modified spectral domain method without numerical calculations in the complex plane. Expressed in transmission line components, this corresponds to the calculation of the resistance and kinetic inductance of the structure. The numerical analysis is applied to coplanar waveguide transmission lines.

The suitability of the method is demonstrated by the investigation of experimental YBa₂Cu₃O_{7-x} coplanar waveguide resonators. It is not possible to obtain a high slowing factor using a coplanar waveguide with reasonable dimensions. The uniplanar metallization makes the transmitted energy much less sensitive to the separation of the strips than in the case of microstrip lines. However the effect of the surface reactance on the resonance frequency of the resonator is significant enough to determine the penetration depth. Results for the surface resistance are obtained from the observed quality factor of the resonator. Investigations of the surface impedance (surface resistance and penetration depth) are of importance, since these can help to clarify the nature of the high-temperature superconductors. The lack of a detailed picture of the couplingmechanism of the electrons in these superconductors is accompanied by observations of non-BCS behavior [6], [7].

We start with an analysis of the surface impedance of a superconducting or normal film of arbitrary thickness. This also naturally leads to the complex resistive boundary conditions in the case of very thin films.

II. THEORY

A. Surface Impedance of a Film of Arbitrary Thickness

To investigate the surface impedance of a superconducting film, we first demonstrate how the Maxwell equations have

to be modified, assuming the two-fluid model and the London equations give a valid description of the superconductor. Despite the phenomenological nature, much of the characteristic features of the electrodynamics is easily visualized by this approach, at least qualitively.

The electrons in a superconductor can be divided in normal and superconducting electrons, according to the two-fluid model. Therefore the total current density $J=J_n+J_s$ consists of a dissipative normal part J_n and a superconducting dissipationless part J_s . The normal part J_n corresponds to the conductivity of the normal electrons:

$$\boldsymbol{J}_n = \sigma_n \boldsymbol{E},\tag{1}$$

giving rise to power losses. The superconducting electrons are described by the London equation [8]:

$$\frac{\partial \boldsymbol{J}_s}{\partial t} = \frac{\boldsymbol{E}}{\mu_0 \lambda^2},\tag{2}$$

which represents the free acceleration of the electrons in an electric field. The magnetic penetration depth is denoted by λ .

For time-harmonic electric fields, (1) and (2) can be incorporated in the first Maxwell equation $\nabla \times \mathbf{H} = y\mathbf{E}$, provided y is written as:

$$y = \sigma + j\omega\varepsilon. \tag{3}$$

Here the complex conductivity is defined as:

$$\sigma = \sigma_n - j\sigma_s,\tag{4}$$

with:

$$\sigma_s = \frac{1}{\omega \mu_0 \lambda^2}. (5)$$

In (3) the last term represents the displacement current. The case of a normal conductor is obtained by setting $\sigma_s = 0$.

The second Maxwell equation $\nabla \times \boldsymbol{E} = -z\boldsymbol{H}$ remains unchanged:

$$z = j\omega\mu_0. \tag{6}$$

So the two-fluid model and the London equations lead to the introduction of a complex conductivity. Although this complex conductivity is a result of the phenomenological London equations, a comparison can be made with more theoretically based results for the complex conductivity [9]. This yields values for σ_n and λ on the basis of the BCS theory. It is also possible to use the phenomenological Gorter-Casimir expressions [10] for σ_n and λ .

The interpretation of the complex conductivity is made clear by manipulating the two Maxwell equations to obtain for the supplied time-averaged complex power density \overline{p}_s :

$$\overline{p}_{s} = -\frac{1}{2}\nabla \cdot (\boldsymbol{E} \times \boldsymbol{H}^{*})
= \frac{1}{2}\sigma_{n}|\boldsymbol{E}|^{2} + \frac{1}{2}j\omega\mu_{0}(\lambda^{2}|\boldsymbol{J}_{s}|^{2} + |\boldsymbol{H}|^{2}) - \frac{1}{2}j\omega\varepsilon|\boldsymbol{E}|^{2}
= \overline{p}_{d} + 2j\omega(\overline{w}_{K} + \overline{w}_{M} - \overline{w}_{E}).$$
(7)

So the normal (real) part of the conductivity corresponds to a dissipated power density \overline{p}_d , while the superconducting

(imaginary) part is related to the kinetic energy density \overline{w}_K of the superconducting electrons. In (7) \overline{w}_M and \overline{w}_E are the stored magnetic and electric energy densities (all quantities time-averaged).

Expression (7) will be used to evaluate the kinetic and magnetic inductance of an infinite film of arbitrary thickness t. First we develop expressions related to the complex power. In the following the displacement current will be neglected, which is a good approximation for most conductors at microwave frequencies.

We consider plane waves, propagating in the z-direction, perpendicular to the film. The film boundaries are located at z=0 and z=t. The magnetic and electric field in the interior of the film are given by [11]:

$$H_y(z) = H_{01}e^{-jkz} + H_{02}e^{jkz}, \tag{8}$$

$$E_x(z) = \eta (H_{01}e^{-jkz} - H_{02}e^{jkz}).$$

$$0 < z < t$$
(9)

The wave number k and the intrinsic impedance η follow from the Maxwell equations:

$$k = \sqrt{-zy},\tag{10}$$

$$\eta = \sqrt{z/y}. (11)$$

In the case of a normal conductor this yields:

$$k = \sqrt{\omega \mu_0 \sigma_n / 2} (1 - j)$$

= $(1 - j) / \delta$, (12)

$$\eta = \sqrt{\omega \mu_0 / 2\sigma_n} (1+j)$$

$$= \frac{1}{2} \omega \mu_0 \delta(1+j), \tag{13}$$

where δ is the classical skin depth:

$$\delta = \sqrt{2/\omega\mu_0\sigma_n}. (14)$$

For a superconductor k and η are given by (assuming $\sigma_n \ll \sigma_s$):

$$k = \sqrt{\omega \mu_0 \sigma_s} (\sigma_n / 2\sigma_s - j)$$

= $((\lambda/\delta)^2 - j)/\lambda$, (15)

$$\eta = \sqrt{\omega \mu_0 / \sigma_s} (\sigma_n / 2\sigma_s + j)
= \omega \mu_0 \lambda ((\lambda / \delta)^2 + j).$$
(16)

We will see that $R_s = \operatorname{Re}(\eta)$ is related to power losses, while $X_s = \operatorname{Im}(\eta)$ is a measure of the stored energy. So in superconductors the power losses are usually much smaller than the stored energy $(\lambda \ll \delta \text{ for } \sigma_n \ll \sigma_s)$. In addition, in this case the power losses are much smaller than in a normal conductor.

Invoking tangential continuity of H at the boundaries, $H_y(0) = H_1, H_y(t) = H_2$, yields:

$$H_n(z) = [H_1 \sin(k(t-z)) + H_2 \sin(kz)] / \sin(kt), \quad (17)$$

$$E_x(z) = \eta [H_1 \cos(k(t-z)) - H_2 \cos(kz)]/j \sin(kt).$$
 (18)

The complex power supplied to the film per unit area is evaluated as:

$$P = \frac{1}{2}E_x(0) \times H_y^*(0) - \frac{1}{2}E_x(t) \times H_y^*(t)$$

= $\frac{1}{2}Z_{s1}|H_1 - H_2|^2 + \frac{1}{2}Z_{s2}(|H_1|^2 + |H_2|^2),$ (19)

where the effective surface impedances Z_{s1} and Z_{s2} are defined:

$$Z_{s1} = \frac{\eta}{i\sin\left(kt\right)},\tag{20}$$

$$Z_{s2} = \eta \frac{\cos(kt) - 1}{j\sin(kt)}.$$
 (21)

Two limiting cases are of particular interest. Firstly, for a very thin film $(|kt| \ll 1, \text{ i.e., } t \ll \lambda, \delta)$ we have:

$$Z_{s1} = \frac{\eta}{jkt} = \frac{1}{\sigma t},$$

$$Z_{s2} = \frac{1}{2}j\omega\mu_0 t, \qquad (t \ll \lambda, \delta)$$
(22)

while in the case of a relatively thick film:

$$Z_{s1} = 0, Z_{s2} = \eta \qquad (t \gg \lambda, \delta) \tag{23}$$

Thus the second term in (19) is dominant if $t\gg\lambda,\delta$, which actually is the bulk material case. Indeed we find the well-known expression for the complex power [11], with the addition that the magnetic field at both film boundaries contributes. In this case the surface impedance equals the intrinsic wave impedance. For $t\ll\lambda,\delta$ only the first term in (19) survives. In this case the impedance depends inversely proportional on the thickness of the film. To be specific:

$$R_{s1} = R_s 2\lambda/t, \qquad (t \ll \lambda, \delta)$$
 (24)

$$X_{s1} = X_s \lambda / t. \tag{25}$$

Here R_s and X_s denote the surface resistance and reactance for bulk material: $\eta=R_s+jX_s$. So for very thin films, the effective surface resistance is by a factor $2\lambda/t$ higher than the bulk value, the surface reactance by a factor λ/t . This correction should be kept in mind when data for very thin films are to be interpreted.

In the intermediate range of thicknesses, the complex power depends on the exact values of H_1 and H_2 . In general no overall impedance can be defined uniquely. An exception occurs if the field is confined to one side of the film $(H_1$ or $H_2=0)$, meaning that the film represents a real wall. Then the surface impedance reads as:

$$Z_s = -j\eta \cot(kt), (H_1 \text{ or } H_2 = 0)$$
 (26)

which is in agreement with the usual expression for this case [12].

The general pattern of Z_{s1} and Z_{s2} is shown in Fig. 1 at a frequency f=10 GHz, with a penetration depth $\lambda=100$ nm and skin depth $\delta=100\,\lambda$. Clearly, Z_{s1} reaches its limiting value (see (24), (25)) not far below $t/\lambda=1$. For Z_{s2} to

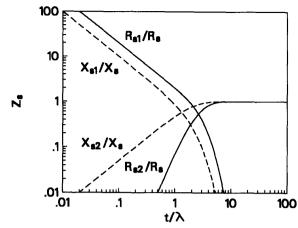


Fig. 1. The effective surface impedances $Z_{s1} = R_{s1} + jX_{s1}$ (dominant if $t \ll \lambda$) and $Z_{s2} = R_{s2} + jX_{s2}$ (dominant if $t \gg \lambda$) as a function of t/λ . The resistive and reactive parts are normalized to the quantities of bulk material $(t \gg \lambda)$.

reach its limiting value (23) for $t>\lambda$ a somewhat stronger condition on t/λ is required; depending on the acceptable errors, the value of t/λ can be as high as approximately 5. The difference in the asymptotic behavior of Z_{s1} and Z_{s2} can be understood, recalling that the current density at both sides of the film falls off as $\exp{(-d/\lambda)}$ inside the conductor, where d is the distance from the boundary of the film. As soon as t becomes comparable to λ or smaller, the current density inside the film is almost uniform. However, if the current density is to die out in the interior of the conductor, the distance to both sides of the film should be several penetration depths.

We now turn to the calculation of the kinetic inductance L_K and the magnetic inductance L_M for an infinite film. Per unit length those inductances are related to the time-averaged kinetic and magnetic energy density through (cf. equation (7)):

$$\frac{1}{4}(L_K + L_M)|I|^2 = \overline{W}_K + \overline{W}_M = \frac{1}{2\omega} \int \int \operatorname{Im}\left(\overline{p}_s\right) dy \, dz. \tag{27}$$

Here I is the amplitude of the total current through the film:

$$I = \int \int J_s \, dy \, dz = (H_1 - H_2)w, \tag{28}$$

where w is the width of the film. From (27) we obtain for L_K and L_M :

$$L_K = \mu_0 \lambda^2 \int \int |J_s|^2 \, dy \, dz / I^2,$$
 (29)

$$L_M = \mu_0 \int \int |H|^2 \, dy \, dz / I^2. \tag{30}$$

Again two limiting cases are considered. The inductances L_K and L_M are equal for $t\gg \lambda,\delta$, because (neglecting σ_n):

$$\left|\frac{H}{J_s}\right|^2 = \left|\frac{H}{E}\right|^2 \left|\frac{E}{J_s}\right|^2 = |\eta\sigma|^{-2} = \lambda^2.$$
 (31)

Evaluating the integrals yields in this transversely uniform case:

$$L_K = L_M = \frac{\mu_0 \lambda}{2w}. \qquad (t \gg t, \delta)$$
 (32)

The property of equal L_K and L_M is generally valid for bulk superconductors [13]. For a very thin film on the other hand, we obtain for L_K :

$$L_K = \frac{\mu_0 \lambda^2}{wt}, \qquad (t \ll \lambda, \delta)$$
 (33)

while L_M approaches zero. Thus in this range of thicknesses L_K is a factor $2\lambda/t$ higher than in the case of relatively thick films. The increased value of L_K results in a higher slowing factor of the electromagnetic waves. The accompanying increase in the losses is usually not a problem, since R_s is very low for superconductors, cf. (24). Structures with a high slowing factor contribute to the realization of very compact microwave circuits [3], [4]. In addition, by measuring the slowwave behavior it is possible to determine λ , because of the role it plays in L_K .

B. Propagation Characteristics of Wave-Guiding Structures with Non-Perfect Conductors

In commonly used wave-guiding structures, we are not dealing with plane waves, as was supposed in the previous section. In general the modes are at best quasi-TEM, but generally hybrid of nature. We will analyze the influence of a non-perfect conducting (i.e., normal or superconducting) metallization with the restriction to the case of very thin films, where the thickness t of the metallization is much smaller than the penetration depth λ and the skin depth δ : $t \ll \lambda$, δ . In this limit it can be shown on the basis of (17) and (18) that the boundary conditions for plane waves can be expressed as:

$$\boldsymbol{E}_1 = \boldsymbol{E}_2 = \boldsymbol{R}\boldsymbol{j},\tag{34}$$

$$\boldsymbol{n} \times (\boldsymbol{H}_1 - \boldsymbol{H}_2) = \boldsymbol{j},\tag{35}$$

with:

$$R = \frac{1}{\sigma t} = Z_{s1}.\tag{36}$$

The subscripts 1 and 2 refer to both sides of the film. The quantity j denotes the total current density per unit length through the cross-section of the film, n is a unit normal vector to the film.

It is assumed that the complex resistive boundary conditions (34) and (35) locally remain valid for non-plane waves. This is an approximation, especially at the sharp corners of the metallization. However, the method has been proved to be quite accurate [5].

The spectral domain method can be applied for a full wave analysis of different wave-guiding structures, such as coplanar waveguide transmission lines (Fig. 2) [14]. The fact that the metallization strips are non-perfect very thin conductors is taken into account by a modification of this method through the complex resistive boundary conditions (34) and (35), as pointed out by Pond *et al.* [5]. Subsequent application of the modified spectral domain method can be found in several works [15], [16].

In short, the electric field at the strips interface $(x = h_1 + h_2)$ is expressed in terms of the current density in the strips by means of the so-called dyadic Green's function. The Green's function corresponds to the case of perfect conductors of zero

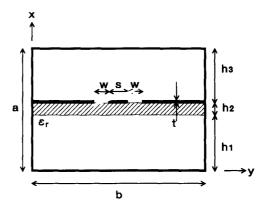


Fig. 2. Geometry of a coplanar waveguide enclosed in a box with strips of thickness t. Unless otherwise stated, the spectral domain calculations are performed at a frequency f=10 GHz with geometrical parameters $\varepsilon_r=10$, and $a=18,b=10,s=0.5,w=0.2,h_1=9,h_2=0.635$, and $h_3=8.365$ mm.

thickness. In this limit the edge condition [17] implies that the tangential field and current components behave like $\rho^{-1/2}$ for vanishing radial distance ρ from the edge. Invoking boundary condition (34) establishes a relation between the electric field in the slots and the currents in the strips. The electric field in the slots is expanded into a set of basis functions. If these basis functions are chosen to satisfy the edge condition, normally only a few basis functions are needed for an accurate description of the field pattern. The drawback of this approach is the appearance of a logarithmic divergence for quantities which involve the integration of the squared field or current components [18], [19]. In the presentation of the numerical results we will discuss this problem in more detail.

The electric field in the slots and the currents in the strips are non-zero in complementary regions. This means that Galerkin's method can be applied to obtain a homogeneous system of linear equations with the weighting factors in the series of basis functions as unknown coefficients [20]. The propagation constant γ of the structure corresponds with non-trivial solutions of this system of equations, meaning a determinant of zero:

$$\det\left[\overline{Z}(j\gamma, jZ_{s1})\right] = 0. \tag{37}$$

Here, \overline{Z} denotes the matrix corresponding to the system of equations.

In general the propagation constant is a complex number with attenuation constant α and wave number β : $\gamma = \alpha + j\beta$. This would imply the use of a root finding algorithm in the complex plane. However, in the lossless case $(R_{s1}=0)$ and $\alpha=0$ the determinant is real, as is emphasized by the arguments $j\gamma$ and jZ_{s1} . Then (37) becomes:

$$\det\left[\overline{Z}(-\beta, -X_{s1})\right] = 0. \tag{38}$$

In the case of a small amount of conductor losses in the strips, it is also possible to calculate the attenuation constant α without explicit complex numerical computation. This is demonstrated as follows. If the losses are low, the solution of

(37) can be approximated by:

$$0 = \det \left[\overline{Z}(-\beta + j\alpha, -X_{s1} + jR_{s1}) \right]$$

$$\simeq \det \left[\overline{Z}(-\beta, -X_{s1}) \right] + \frac{\partial \det \left[\overline{Z}(-\beta, -X_{s1}) \right]}{\partial (-\beta)} j\alpha$$

$$+ \frac{\partial \det \left[\overline{Z}(-\beta, -X_{x1}) \right]}{\partial (-X_{s1})} jR_{s1}. \tag{39}$$

Here the first term in the right hand side corresponds to the lossless case, (38). It is assumed that β remains unchanged in the presence of losses, which is reasonable in the low-loss case. This assumption agrees with the usual perturbational approach in calculating the attenuation constant. As a result, the term for the lossless case still satisfies (38), from which we obtain:

$$\alpha = -R_{s1} \frac{\partial \det [\overline{Z}]}{\partial X_{s1}} \left(\frac{\partial \det [\overline{Z}]}{\partial \beta} \right)^{-1}$$

$$= R_{s1} \frac{\partial \beta}{\partial X_{s1}}.$$
(40)

If the relation between β and X_{s1} is already known the last expression can be used. Otherwise it is advantageous to use the expression with the differentials of det. These differentials correspond to the zero-loss case, which implies that only real operations are involved in the calculation of α . For compactness of notation we will use the last expression of (40) hereafter. If necessary, $\partial \beta/\partial X_{s1}$ can be calculated on the basis of the determinant.

Relation (40) is also useful in determining the kinetic inductance L_K of structures with thin superconducting strips, which is not only dependent on X_{s1} , but also on the current density distribution, cf. equation (29). Only for a uniform current density, L_K is given by (33):

$$L_S = \frac{\mu_0 \lambda^2}{st} = \frac{X_{s1}}{\omega s},\tag{41}$$

where s denotes the width of the strip. Generally L_K will be larger. To establish a relation between (40) and L_K,α is written as:

$$\alpha = \frac{\overline{P}_d}{2\overline{P}_f} = \frac{\frac{1}{2}R_{s1}\int_{\text{strips}}|J|^2 dS}{I^2 Z_0}.$$
 (42)

Here \overline{P}_d is the time-averaged dissipated power in the strips, \overline{P}_f is the time-averaged power transmitted through the structure, Z_0 is the characteristic impedance defined on the basis of power \overline{P}_f and current I through one of the strips. In principle any of the strips can be used as the reference strip for the definition of L_S and Z_0 . It is common practice to use the strip which carries the signal for this purpose. In cases where it is not possible to identify the signal strip uniquely (e.g., slotlines) this can lead to a somewhat unconventional definition of Z_0 . However the analysis remains valid as long as the same strip is used as the reference in L_S and Z_0 . Comparing (42) with the definition of L_K , (29), and using (40) yields $(J_n \ll J_s)$:

$$\frac{L_K}{L_S} = 2sZ_0 \frac{\partial \beta}{\partial X_{s1}}. (43)$$

In L_K the contribution of all strips is included. The walls of the box are assumed to be perfectly conducting.

As an illustrative example of the foregoing we consider the case of the parallel-plate transmission line, which can be treated analytically [21]. For simplicity it is assumed that one of the plates is perfectly conducting. The separation between the plates is denoted by d, the permittivity by ε . Then, for $t \ll \lambda, \delta$, (18) of Swihart [21] reads as:

$$\beta = \omega(\varepsilon \mu_0)^{1/2} \sqrt{1 + X_{s1}/\omega \mu_0 d}. \tag{44}$$

Using $R_{s1} = (\omega \mu_0)^2 \lambda^4 \sigma_n / t$ ((14), (16) and (24)), evaluation of (40) yields:

$$\alpha = \frac{\omega^2}{2d} (\varepsilon \mu_0)^{1/2} \frac{\mu_0 \sigma_n \lambda^4 / t}{\sqrt{1 + \lambda^2 / dt}},\tag{45}$$

which is in agreement with (37) of Swihart. Even in this analytical example it is profitable that we arrive at the correct expression for α , without manipulating complex numbers. Also, with the help of (43), we readily obtain: $L_K/L_S=1$, as it should be for an uniform current distribution.

Concluding, the dependence of the complex propagation constant of different wave-guiding structures on the surface impedance of the strips can be evaluated by means of (38) and (40), without the numerical use of complex numbers. Equation (43) describes an efficient way of calculating the kinetic inductance of the structure.

III. NUMERICAL RESULTS

The modified spectral domain method, as formulated in Section II-B, is applied for a full wave analysis of the propagation characteristics of coplanar waveguide (Fig. 2). Particularly the dependence of the complex propagation constant and the kinetic inductance on the surface impedance will be analyzed. We also pay attention to the convergence of the numerical solution.

The walls of the box are perfectly conducting, whereas the thickness of the superconducting strips is much smaller than the penetration depth and the skin depth: $t \ll \lambda, \delta$. The components of the electric field in the slots are expanded in terms of the basis functions of [14]. As usual, these basis functions satisfy the edge condition for perfect conductors of zero thickness. This leads to a logarithmic divergence for quantities which involve integration of the current density squared, i.e., the attenuation constant α , (42), and the kinetic inductance L_K , (29). Since both quantities play an important role, and because it is easy to overlook a logarithmic divergence, a critical investigation of the convergence of the numerical solution is necessary.

The convergence is studied as a function of the number of basis function terms M and as a function of the number of Fourier terms N. The required number M is mainly dependent on the extent to which the basis functions resemble the actual field pattern. Evidently, fast variations of the basis functions, such as the divergence near the edge, are better approximated by increasing N.

As usual no problems are encountered in finding the wave number β , if the surface impedance is neglected. This case corresponds to solving (38) with $X_{s1}=0$. Fig. 3(a) shows the solution of the wave number β , normalized to the wave number k_0 in free space, for different M and N. Values of

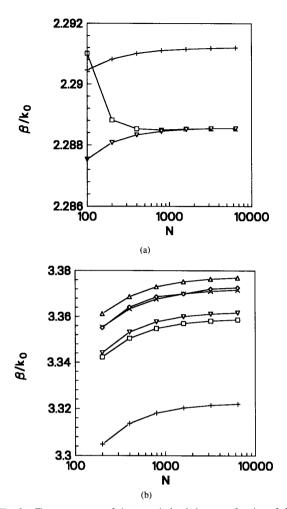


Fig. 3. The convergence of the numerical solution as a function of the number of Fourier terms N for different values of the number of basis function terms $M\colon M=1(+),2(\square),3(\bigtriangledown),4(\times),5(\diamondsuit),$ and $6\ (\triangle)$. Shown are the results of the normalized wave number β/k_0 for $L_S=0$ (a) and $L_S=300$ nH/m (b).

M higher than 3 give practically the same results as M=2 and M=3 for even and odd M respectively. The solution converges to a limiting value, which is constant for M>1. Using M=1 and N=100 introduces only an error of 0.1%. It turns out that the actual functional dependence of the basis functions is of little importance, as long as they incorporate the edge condition and satisfy the correct symmetry of the field pattern. These satisfactory results are in fact the justification for this established choice of the basis functions.

For $X_{s1} \neq 0$ the divergence near the edge is smeared out as a result of the finite penetration depth. Hence, the basis functions which satisfy the edge condition are less suited to describe the field pattern. Therefore the convergence of β/k_0 with increasing M is slower (Fig. 3(b)), in comparison with the case of $X_{s1} = 0$. However the solution does converge as a function of both M an N. An increase in M is more effective than the same increase in N. A reasonable approximation of the solution is obtained using M = 4 and N = 400 to 800.

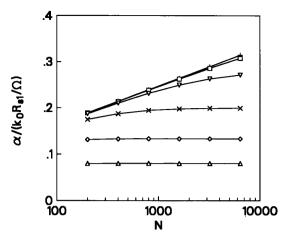


Fig. 4. The convergence of the numerical results for α with increasing number of Fourier terms N for the different values of $L_S:L_S=0(+),0.03(\square),0.3(\bigtriangledown),3(\bigtriangledown),30(\diamondsuit),$ and 300 nH/m (Δ). The calculations are performed with four basis function terms (M=4).

The attenuation constant is calculated according to equation (40) for different values of $L_S=X_{s1}/\omega s$ (Fig. 4). For $L_S=0$ the results clearly exhibit a logarithmic divergence, as has to be expected. Of course the logarithmic divergence is a mathematical artefact. In reality the current density will be peaked near the edges, but never divergent. In general a practical argument is used to overcome this problem. It is stated that the relatively slow divergence is not a serious problem in view of the limited experimental accuracy in measuring α . Indeed, reasonable values of α are obtained [18], but the arbitrariness in the choice of N is questionable. On the other hand it can be argued that the peaked current densities make any kind of analysis very sensitive to small deviations from the model, such as material imperfections and geometrical tolerances.

The rate of convergence steadily increases for higher values of L_S and λ has an increasing effect in smearing out the divergence near the edges. Because the current density becomes less peaked with increasing L_S the value of α decreases as well. For very small values of L_S the value of α is bounded as N goes to infinity. However, it seems unrealistic that for instance as many as 10^5 Fourier terms are needed to obtain the correct α . Presumably the validity of such a calculation breaks down because of a small amount of losses. Thus theoretically the calculation of α presents no problem for small L_S , since α is bounded. However practically problems are encountered in much the same way as in the case of $L_S=0$. It is clear from Fig. 4 that this ambiguity in the calculation of α ceases to exist for higher values of L_S . As we will see, this corresponds exactly to the case of experimental interest.

By virtue of (40), the slow convergence of α/R_{s1} for small L_S also causes β to be slowly convergent with N. This is confirmed if we take a close look at the results for β . However, small values of L_S cause a small change in β . Hence the slow convergence of this small change is only observed at a scale which is far beyond any practical demand of accuracy. For higher values of L_S (= $X_{s1}/\omega s$) the quantity $\partial \beta/\partial X_{s1}$ can

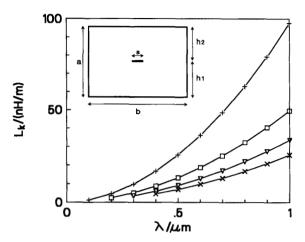


Fig. 5. The kinetic inductance L_K of a stripline (see inset) as a function of the penetration depth λ for different strip thicknesses $t\left(M=4,N=800\right)$: $t=0.1(+),0.2(\Box),0.3(\bigtriangledown),0.4\,\mu\mathrm{m}(\times)$. The walls of the box are assumed to be perfectly conducting. The geometrical parameters are: $a=846\,\mu\mathrm{m},b=2000\,\mu\mathrm{m},s=150\,\mu\mathrm{m}$, and $h_1=h_2=432\,\mu\mathrm{m}$.

be integrated to obtain β , which means that the resultant rate of convergence of β for a specific value of L_S is an accumulation of the rate of convergence of α for smaller values of L_S . This explains why β is converging slower with the number of Fourier terms N as L_S increases (Fig. 3).

In order to test the validity of the formulation of Section II-B for calculating α and L_K , we will compare our results with two other works. Sheen et al. [22] have analyzed a stripline configuration with a metallization of arbitrary thickness. The conductors, which obey the two-fluid model, are subdivided in small patches. From the transmission line equation of the resultant system of coupled transmission lines, the current distribution, resistance and inductance of the transmission line are calculated. We can use the Green's function of a coplanar waveguide for an analysis of the stripline configuration by setting w = 1/2(b-s) and $\varepsilon_r = 1$. As mentioned before, the walls are assumed to be perfectly conducting. This is in contrast to the model of [22], in which the top and bottom wall are superconducting and the sidewalls are not present. However, the main contribution to the kinetic inductance L_K will arise from the central strip, since the currents are most strongly peaked here. The influence of the sidewalls can be neglected, provided the distance b between these walls is not too small. To limit the number of Fourier terms needed we have performed the calculations with $b = 2000 \, \mu \mathrm{m}$. The results for L_K on the basis of (43) are presented in Fig. 5 as a function of the penetration depth λ for different thicknesses $t(\lambda > t)$ of the central strip. Despite the differences in geometry the agreement with the results of Sheen et al. [22] (Fig. 6) is good. This strongly indicates the validity of both methods, as both are based on a different computational scheme.

Pond et al. [5] have calculated the complex propagation constant γ of microstrip lines with very thin superconductors $(t \ll \lambda)$, by means of solving equation (37). No numerical operations in the complex plane are necessary if we use the alternative expression (40). The results for α , based on

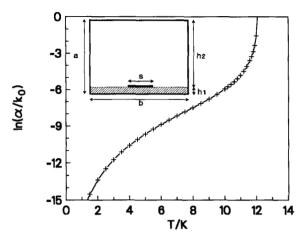


Fig. 6. The normalized attenuation constant of a microstrip line (see inset) with a strip of thickness t=14.5 nm at a frequency f=1 GHz (M=4, N=800). The microstrip line is enclosed in a perfectly conducting box. The geometrical parameters are: $\varepsilon_r=10.5$, and $a=b=100~\mu\text{m.}\,s=25~\mu\text{m.}\,h_1=2.25~\mu\text{m.}$, and $h_2=97.75~\mu\text{m.}$ The two-fluid model of Gorter and Casimir is used with $T_c=12.15~\text{K}$, $\lambda_0=320$ nm, and $\sigma_{nc}=10^6~(\Omega\text{m})^{-1}$.

(40), are shown in Fig. 6 and are seen to be in excellent agreement with Fig. 9 of [5]. Again a different configuration is handled within the framework of coplanar waveguide, this time by setting w=1/2(b-s) and $h_1\to 0$. In order to make the results directly comparable, we have calculated the absolute value of α by inserting the dependences of the two-fluid model of Gorter and Casimir, $\sigma_n=\sigma_{nc}(T/T_c)^4$ and $\lambda=\lambda_0/(1-(T/T_c)^4)^{1/2}$, in $R_{s1}=(\omega\mu_0)^2\lambda^4\sigma_n/t$. The conductivity just above the critical temperature is denoted by σ_{nc} , the zero-temperature penetration depth by λ_0 .

The foregoing demonstrates that the results of the formulation described in Section II-B and those of other methods are similar. For everyday use it is convenient to have the disposal of an empirical relation between the surface impedance and the propagation constant. For this purpose a description of L_K/L_S as a function of L_S is sufficient:

$$\frac{L_K}{L_S} = F(L_S). (46)$$

Fig. 7 shows the numerical results of L_K/L_S , calculated according to (43), for different values of w. These data are very well represented by the function:

$$F(L_S) = A + Be^{-\{0.14 \cdot \ln{(50L_S[nH/m])}\}^C}$$
 (47)

where A, B, and C are geometry-specific fitting parameters. For quasi-TEM modes the parameters A, B, and C depend only weakly on the dielectric constant (and therefore h_2) and frequency, because the dielectric constant has little effect on the inductance and because the dispersion is relatively low for these modes. The parameters also depend on the number of Fourier terms N. However, in the cases of practical interest, meaning an appreciable magnitude of L_S , the value of $F(L_S)$ is changing slowly with N.

A transmission line model is applicable for structures, which support a quasi-TEM mode (e.g., microstrip lines and coplanar waveguides). From such a model we obtain:

$$\beta = \beta_0 \left(\frac{L_K}{L} + 1\right)^{1/2},\tag{48}$$

with the wave number β_0 of the structure with perfect metallization $(L_S=0)$, and the geometrical inductance $L=(\beta_0/k_0)Z_0/c_0$, which is only moderately dependent on $L_S;c_0$ is the phase velocity in free space. Closed-form expressions are available for the wave number β_0 and the characteristic impedance Z_0 [23], [24]. From (48) it also is clear that the influence of L_K is only significant if it is an appreciable portion of L.

The equations (46) to (48) establish a relation between β and L_S or, equivalently, X_{s1} . Then, invoking (40), α/R_{s1} is also known for a particular X_{s1} .

IV. EXPERIMENTAL RESULTS

We have measured the resonance frequency f_0 and the unloaded quality factor Q_0 of $YBa_2Cu_3O_{7-x}$ coplanar waveguide resonators, as described in [25]. The measurements are performed in the temperature range of 4.2 to 80 K at excitation levels for which the data are independent of incident microwave power (-30 dBm). The thin films are deposited on sapphire substrates by off-axis rf magnetron sputtering [26]. A c-axis oriented $YBa_2Cu_3O_{7-x}$ layer is separated from the substrate by a $PrBa_2Cu_3O_{7-x}$ buffer layer, both layers having a thickness of 50 nm. The buffer layer blocks the interdiffusion between $YBa_2Cu_3O_{7-x}$ and sapphire effectively [27]. Moreover, the $PrBa_2Cu_3O_{7-x}$ material has similar lattice constants and the same perovskite structure as $YBa_2Cu_3O_{7-x}$, resulting in an improved lattice-match.

The normalized wave number $\beta/k_0=c_0/2lf_0$ follows from the resonance frequency f_0 , the length l of the resonator, and the phase velocity c_0 in free space. The relevant length of the resonator is slightly different from its physical length (5.4 mm) by open-end effects. The wave number β is influenced by the field penetration into the superconductor or by the kinetic inductance of the transmission line. From the numerical analysis of Section III we have an empirical relation between β and $L_S = \mu_0 \lambda^2 / st$, which can be inverted to obtain λ from β . We are dealing with small values of L_S/L of the order of a few percent; the geometrical inductance is evaluated as $L = (\beta_0/k_0)Z_0/c_0 = 377 \text{ nH/m} (s = 0.5 \text{ mm}, w = 0.2 \text{ mm}),$ using the closed-form expressions of [24], and L_S is estimated as $L_S = \mu_0 \lambda^2 / st \approx 2$ nH/m for $\lambda \approx 200$ nm, s = 0.5 mm, and t = 50 nm. If L_S is only a small fraction of L, relatively small changes in β correspond to significant changes in L_S , cf. (48). This illustrates the difficulty that for small L_S/L both the wave number for $L_S = 0, \beta_0$, and the length l of the resonator need to be known with high accuracy. The former quantity (β_0) is not known experimentally $(L_S \neq 0 \text{ for } T \rightarrow 0)$, while it is non-trivial to calculate the latter (l) accurately, since this involves open-end effects. Moreover, there are more sources of uncertainty, such as the dielectric anisotropy of sapphire [28].

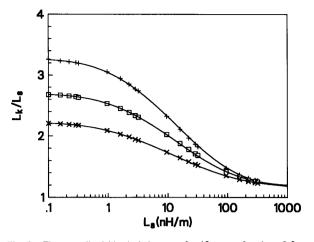


Fig. 7. The normalized kinetic inductance L_K/L_S as a function of L_S for coplanar waveguides (Fig. 2). The data points are the spectral domain results for $w=0.1(+), w=0.2(\square)$, and w=0.5 mm (×). The lines are the result of a fit to (47) with parameters: A=1.164, B=2.096, and C=3.666(w=0.1 mm); A=1.188, B=1.497, and C=3.661(w=0.2 mm); A=1.173, B=1.042, and C=3.362(w=0.5 mm).

Therefore a more practical procedure is applied to determine β_0 and 1. The results for λ are fitted to the temperature dependence of the two-fluid model of Gorter and Casimir, $\lambda =$ $\lambda_0/(1-(T/T_c)^4)^{1/2}$, with the free parameters l, λ_0 , and T_c . Such a self-consistent treatment of the data is commonly used, even in cases of a small geometry (delay lines), where much higher values of L_S/L are possible [29]. The procedure turns out to be satisfactory, since slightly different values of β_0 lead to somewhat different values of l, but to practically the same λ_0 . The values of A, B, and C from the empirical relation (47) are not very critical as well. We use $\beta_0/k_0 = 2.3367$, which is the spectral domain result for s=0.5 mm, w=0.2 mm, $h_2 = 1.135$ mm, $\varepsilon_r = 10$, and f = 10 GHz. The value of h_2 follows from the thickness of the sapphire substrate (0.5 mm), which is surface mounted on an alumina motherboard (25 mil). The parameters A, B, and C are only weakly dependent on h_2 , as mentioned before, which implies that we can use the values shown in Fig. 7 ($h_2 = 0.635$ mm): A = 1.188, B = 1.497, and C = 3.661. Within the same approximation we can ignore the difference between the frequency used in the calculations (10 GHz) and the observed resonance frequency (≈11 GHz). In this way we obtain l=5.695 mm, $\lambda_0=250$ nm, and $T_c = 86$ K. The critical temperature T_c is consistent with dc-resistance measurements.

The temperature dependence of the inferred λ is examined in more detail by plotting the relative change $(\lambda(T)-\lambda(0))/\lambda(0)$ versus temperature (Fig. 8). Also shown are the temperature dependencies of the two-fluid model (solid) and the Mattis-Bardeen (MB) theory [9], for two different values of the energy gap parameter: $2\Delta_0/kT_c=3.5$ (dashed) and $2\Delta_0/kT_c=4.8$ (dot-dashed). The MB temperature dependence of λ changes slowly with the electron man free path l. The curves shown in Fig. 8 correspond to $l/\pi\xi_0=2$. The MB theory is used in the local limit [30], where the field variation across the size of the Cooper pairs can be neglected, because the zero-temperature

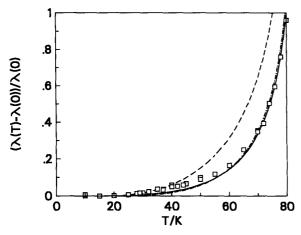


Fig. 8. Experimental results of the relative change of the penetration depth, $(\lambda(T)-\lambda(0))/\lambda(0)$, with temperature $T(\Box)$. The curves represent the two-fluid model (solid), and the MB theory with $l/\pi\xi_0=2$. $\lambda_0=140$ nm, and the gap parameters $2\Delta_0/kT_c=3.5$ (dashed) and $2\Delta_0/kT_c=4.8$ (dot-dashed),

coherence length ξ_0 is much smaller than the penetration depth λ_0 at zero temperature. This limit is appropriate for high-temperature superconductors, since ξ_0 is of the order of a few nm in these materials, while λ_0 is of the order of several hundred nm. Less clear is the validity of isotropic pairing, as is assumed in the MB theory. However, a detailed picture of the coupling in high-temperature superconductors is not available.

The experimental results agree with a gap parameter $2\Delta_0/kT_c=3.5$ for lower temperatures $(T\lesssim 0.5T_c)$, while the data for $T\gtrsim 0.5T_c$ are better represented by $2\Delta_0/kT_c=4.8$. The value of 3.5 agrees with the BCS weak-coupling limit [31], the value of 4.8 is comparable to results of other works, where values of 4.3 to 5 are reported for the same temperature range [6], [32], [33]. The two-fluid model closely resembles the MB theory for $2\Delta_0/kT_c=4.8$, despite the usual application of this model to superconductors in the weak-coupling limit $(2\Delta_0/kT_c=3.53)$. This is caused by the fact that the zero-temperature penetration depth λ_0 in the two-fluid model should be somewhat higher than λ_0 in the BCS weak-coupling limit in order to obtain agreement for temperatures near T_c .

Thus the results over the entire temperature range are not consistent with a single-gap BCS temperature dependence, which confirms the results of [6]. Possibly this can be attributed to the presence of weak links in the material [34], [35], which also explains the reduced critical temperature $T_c=86$ K and the increased penetration depth $\lambda_0=250$ nm, compared to the more or less established intrinsic value $\lambda_{I0}=140$ nm [6], [33]. The influence of weak links is accounted for in a model of Hylton et~al.~[36], which predicts that the resultant penetration depth $\lambda=(\lambda_I^2+\lambda_J^2)^{1/2}$ is modified by an effective penetration depth $\lambda_J\propto I_c^{-1/2}$ of the weak lines alone. If we take the weak-link critical current temperature dependence of Ambegaokar-Baratoff [37], $I_c\propto (\Delta/\Delta_0) \tanh{(\Delta/2kT)}$, the temperature dependence of λ_J is the same as the dominant low-temperature MB temperature dependence of λ_I . Therefore

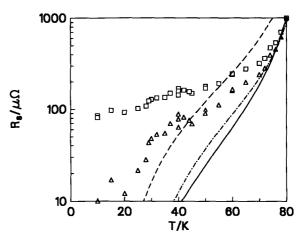


Fig. 9. Experimental results of the surface resistance R_s , absolute (\square) and relative to zero-temperature (Δ). The curves represent the two-fluid model (solid), and the MB theory with $l/\pi\xi_0=2$, $\lambda_0=140$ nm, and the gap parameters $2\Delta_0/kT_c=3.5$ (dashed) and $2\Delta_0/kT_c=4.8$ (dot-dashed).

this temperature dependence does not improve the fit of the experimental results to a single-gap dependence. However, the precise change of I_c with temperature is open to discussion.

Next we turn to the results of R_s , which are deduced from the data Q_0 . By virtue of $Q_0 = \beta/2\alpha$ and (40) we have; $R_s = \beta t/4\lambda Q_0\partial\beta/\partial X_{s1}$, where R_s is the surface resistance of bulk material, cf. (24). With the application of the empirical relations (46) to (48) between β and L_S (or λ), R_s can be calculated from Q_0 , if λ is known. In this case we will use the two-fluid model of Gorter and Casimir to determine λ , which is reasonable over the entire temperature range (Fig. 8).

Fig. 9 shows the results for R_s as a function of temperature (\Box) . As usual, R_s decreases rapidly as the temperature is reduced below T_c . For lower temperatures R_s approaches a constant value, which is an indication of non-intrinsic behavior. The most likely reasons of this residual R_s are the losses in the weak links [34], [35] or the dielectric losses [38]. In any event, the low-temperature value $R_s = 80 \,\mu\Omega$ is much lower than the textbook value of OFHC copper in the same frequency and temperature range, $R_s = 5 \,\mathrm{m}\Omega$. This illustrates the suitability of these films for microwave applications with a high demand on R_s , such as delay lines and high-performance filters. Both the residual R_s and T_c are in remarkable agreement with the results of thin films on sapphire with a SrTiO₃ buffer layer, reported by Char et al. [39] $(R_s = 65\,\mu\Omega$ at 10 GHz, which would imply $R_s = 80\,\mu\Omega$ at 11 GHz according to a quadratic frequency dependence, and a superconducting transition at 87 K with a 1 K transition width). Also shown in Fig. 9 are the results for R_s with the zero-temperature value subtracted, $R_s(T) - R_s(0)$, (Δ) . The aim of this operation is to cancel the non-intrinsic losses, although the temperature dependence of these losses is not necessarily negligible. The data of $R_s(T) - R_s(0)$ at the lowest temperatures should be interpreted with some caution, since the relative errors become large for small differences.

The solid curve represents the two-fluid model with the parameters $\lambda_0=250$ nm and $\sigma_{nc}=3\cdot 10^6\,(\Omega\mathrm{m})^{-1}$, where

 σ_{nc} is the conductivity just above T_c . The other two curves are the results of the MB theory for $l/\pi\xi_0=2, \lambda_0=140$ nm, and gap values $2\Delta_0/kT_c=3.5$ (dashed) and $2\Delta_0/kT_c=4.8$ (dotdashed). The calculations are performed at 11 GHz; the 2% change of the observed resonance frequency with temperature is neglected. In order to match the two-fluid model and the MB theory near T_c , we need a higher value of σ_{nc} at 11 GHz than Drabeck *et al.* [32] at 100 GHz $(1.5 \cdot 10^{-6} (\Omega \text{m})^{-1})$. This is caused by the additional MB frequency dependence $\ln (kT/\hbar\omega)$ of the surface resistance $(\hbar\omega \ll kT)$, which illustrates that we should not take the value of σ_{nc} too serious. The experimental results close to T_c are well represented by $2\Delta_0/kT_c=4.8$. In this temperature range the value of $l/\pi\xi_0 = 2$ is found to give the best agreement with the experimental results. The data at lower temperatures are better described by the other gap parameter $2\Delta_0/kT_c = 3.5$, although it can not be concluded decisively that this is the correct value of the gap for lower temperatures. However the discrepancy with the experimental results is limited in view of the margins of error and the neglect of the influence of temperature with respect to the weak links.

V. CONCLUSIONS

We have analyzed the surface impedance of an infinite normal or superconducting film of arbitrary thickness. The surface reactance X_s of very thin superconducting films ($t \lesssim$ λ) is increased by a factor λ/t compared to X_s of relatively thick films $(t \gg \lambda)$. The surface resistance R_s and the kinetic inductance L_K are increased by a factor $2\lambda/t$. The analysis also shows that in the case of very thin films the boundary conditions for the field agree with the complex boundary conditions [5], which are used in a modification of the spectral domain analysis of different wave-guiding structures.

The influence of the surface impedance Z_s on the propagation constant $\gamma = \alpha + i\beta$ is investigated by means of the modified spectral domain method. We found expressions which allow an efficient calculation of the attenuation constant α and the kinetic inductance L_K . An empirical model of the relation between the wave number β and L_k is presented, which describes the exact results very well.

This model is used to determine the penetration depth λ and the surface resistance R_s from the experimental results for the resonance frequency and the unloaded quality factor of YBa₂Cu₃O_{7-x} coplanar waveguide resonators. The YBa₂Cu₃O_{7-x} layers are deposited on sapphire with a PrBa₂Cu₃O_{7-x} buffer layer. The observation of a low residual surface resistance, $R_s = 80 \,\mu\Omega$, supports the conclusion from other work [27], that the buffer layer prevents interdiffusion, while constituting a suitable basis for epitaxial growth of $YBa_2Cu_3O_{7-x}$.

The results indicate that the temperature dependence of λ and R_s is not characterized by a single-gap BCS temperature dependence. For lower temperatures a conventional BCS weak-coupling gap value $2\Delta_0/kT_c = 3.52$ seems appropriate, while $2\Delta_0/kT_c = 4.8$ describes our findings for higher temperatures. Our results suggest an electron free mean path value $l/\pi \xi_0 = 2$. The origins of non-BCS behavior have

been interpreted in terms of weak links. However, other interpretations [40] can not be ruled out, since the couplingmechanism for electrons in high-temperature superconductors is not clearly understood.

VI. ACKNOWLEDGMENT

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